

## **AMENDMENTS TO THE CLAIMS**

The following listing of claims will replace all prior versions and listings of claims in the application.

### **LISTING OF CLAIMS**

1. – 4. (Cancelled)

5. (Currently Amended) A method for manufacturing an electro-optical device including a flexographic process, comprising:

forming color filters that include a plurality of colors at a first predetermined pitch on a front side of a substrate;

transferring a coating liquid from an anilox roller onto a projection, said projection formed on a letterpress; and

transferring said coating liquid from said projection to said substrate, said coating liquid thereby forming a film on said substrate;

wherein at least two of:

said first predetermined pitch of said color filters of the same color;

a second pitch of meshes formed on a surface of said anilox roller;

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and

a third pitch of meshes formed on a surface of said projection are substantially equal.

6. (Previously Presented) A method for manufacturing an electro-optical device according to claim 5, wherein said predetermined pitch of said color filters, said second pitch of meshes formed on said surface of said anilox roller, and said third pitch of meshes formed on said surface of said projection are substantially equal.

7. (Previously Presented) A method for manufacturing an electro-optical device according to claim 5, wherein said film is an alignment film for controlling an alignment state of an electro-optical substance.

8. (Previously Presented) A method for manufacturing an electro-optical device according to claim 5, wherein said film is formed on a dummy substrate by flexography before said film is formed by flexography on said front side of said substrate.

9. (Currently Amended) A method for manufacturing a liquid crystal device comprising:

(a) providing a transparent substrate operable to be divided into a plurality of smaller discrete substrates;

(b) forming [[a]] color filters at a first predetermined pitch on discrete regions of said ~~on a transparent~~ substrate;

(c) forming a planarizing film on said color filters;

(d) forming an electrode pattern on said planarizing film;

(e) forming an overcoating film on said electrode pattern;

(f) forming an alignment film on said overcoating film; [[and]]

(g) forming a first terminal region and a second terminal region along edges of said discrete regions of said substrate, said edges not containing said overcoating film and said alignment film[[,]]; and

~~wherein said transparent substrate is formed from a large substrate cut into a plurality of transparent substrates, said large substrate is subjected to flexography where a coating liquid is transferred from an anilox roller onto a projection, said projection formed on a letterpress;~~

(h) dividing said substrate into a plurality of discrete substrates containing said color filters,

wherein steps (e) and (f) include:

transferring a coating liquid from an anilox roller onto a projection formed on a letterpress; and

transferring said coating liquid ~~is transferred~~ from said projection to said large substrate ~~[[to]]~~ thereby forming said overcoating film and said alignment film respectively, ~~[[;]]~~ and

at least two of:

~~[[a]]~~said first predetermined pitch of said color filters of the same  
color;

a second pitch of meshes formed on a surface of said anilox roller;

and

a third pitch of meshes formed on a surface of said projection are substantially equal.

10. (Previously Presented) A method for manufacturing a liquid crystal device according to claim 9, wherein said predetermined pitch of said color filters, said second pitch of meshes formed on said surface of said anilox roller, and said third pitch of meshes formed on said surface of said projection are substantially equal.

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